

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Yoshikazu MIYAJIMA et al.)	Examiner: D. J. Rutledge
	:	
Application No.: 10/820,120)	Group Art Unit: 2851
	:	
Filed: April 8, 2004)	Confirmation No.: 8660
	:	
For: STAGE APPARATUS, EXPOSURE SYSTEM)	February 12, 2008
USING THE SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 14, 2007, please amend the above-identified application as follows.